

Applicant: Daniel F. Justin, et al.
 Serial No.: 10/811,038
 Filing Date: 03/26/2004

Docket No. MLI-05 NPROV
 Confirmation No: 9538

Form 1449
 Laser Based Metal Deposition (LBMD) of Implant Structures



INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

U.S. Patent Documents

Examiner Initial*	Document Number	Issue Date	Name
AP 1	US3947653	3/30/1976	Fairbairn; Thomas E.
SC 2	US4048459	9/13/1977	Earle; Michael
3	US4117302	9/26/1978	Earle; Michael et al.
4	US4200669	4/29/1980	Schaefer; Robert J. et al.
5	US4218494	8/19/1980	Belmondo; Armando et al.
6	US4243867	1/6/1981	Earle; Michael et al.
7	US4269868	5/26/1981	Livsey; Norman B.
8	US4284443	8/18/1981	Hilton; R. John
9	US4289952	9/15/1981	Haggerty; John S.
10	US4299860	11/10/1981	Schaefer; Robert J. et al.
11	US4300474	11/17/1981	Livsey;; Norman B.
12	US4323756	4/6/1982	Brown; Clyde O. et al.
13	US4367017	1/4/1983	Jimbou; Ryutarou et al.
14	US4434189	2/28/1984	Zaplatynsky; Isidor
15	US4537793	8/27/1985	Kehrer; Hans-Peter et al.
16	US4568565	2/4/1986	Gupta; Arunava et al.
Q 17	US4603257	7/29/1986	Packer; Louis L. et al.

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18	US4615903	10/7/1986	Miller; Douglas L.
19	US4644127	2/17/1987	La Rocca; Aldo V.
20	US4677274	6/30/1987	Bisiach; Bruno
21	US4681640	7/21/1987	Stanley; Ann E.
22	US4701592	10/20/1987	Cheung; Jeffrey T.
23	US4724299	2/9/1988	Hammek; Albert W.
24	US4732778	3/22/1988	Kawasaki; Minoru
25	US4804815	2/14/1989	Everett; Mark A.
26	US4818562	4/4/1989	Arcella; Frank G. et al.
27	US4832982	5/23/1989	Mori; Kazuhiko et al.
28	US4853250	8/1/1989	Boulos; Maher et al.
29	US4863538	9/5/1989	Deckard; Carl R.
30	US4927992	5/22/1990	Whitlow; Graham A. et al.
31	US4938816	7/3/1990	Beaman; Joseph J. et al.
32	US4944817	7/31/1990	Bourell; David L. et al.
33	US4947463	8/7/1990	Matsuda; Jun et al.
34	US4976930	12/11/1990	Kishida; Shunji et al.
35	US5017753	5/21/1991	Deckard; Carl R.
36	US5038014	8/6/1991	Pratt; Vanon D. et al.
37	US5043548	8/27/1991	Whitney; Eric J. et al.

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38	US5111021	5/5/1992	Jolys; Pascal et al.
39	US5132143	7/21/1992	Deckard; Carl R.
40	US5147680	9/15/1992	Slysh; Paul
41	US5155324	10/13/1992	Deckard; Carl R. et al.
42	US5156697	10/20/1992	Bourell; David L. et al.
43	US5182170	1/26/1993	Marcus; Harris L. et al.
44	US5182430	1/26/1993	Lagain; Georges L.
45	US5208431	5/4/1993	Uchiyama; Futoshi et al.
46	US5245155	9/14/1993	Pratt; Vanon D. et al.
47	US5252264	10/12/1993	Forderhase; Paul F. et al.
48	US5272312	12/21/1993	Jurca; Marius-Christian
49	US5285046	2/8/1994	Hansz; Bernard
50	US5290368	3/1/1994	Gavigan; William J. et al.
51	US5308661	5/3/1994	Feng; Zhu et al.
52	US5314003	5/24/1994	Mackay; Colin A.
53	US5316580	5/31/1994	Deckard; Carl R.
54	US5368947	11/29/1994	Denney; Paul E.
55	US5384523	1/24/1995	Masuda; Teruo
56	US5385780	1/31/1995	Lee; Biing-Lin
57	US5393613	2/28/1995	MacKay; Colin A.

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58	US5393957	2/28/1995	Misawa; Hiroaki et al.
59	US5398193	3/14/1995	deAngelis; Alfredo O.
60	US5413641	5/9/1995	Coulon; Andre
61	US5418350	5/23/1995	Freneaux; Olivier et al.
62	US5431967	7/11/1995	Manthiram; Arumugam et al.
63	US5434880	7/18/1995	Burrows; Graham et al.
64	US5449536	9/12/1995	Funkhouser; Merle E. et al.
65	US5453329	9/26/1995	Everett; Mark A. et al.
66	US5471541	11/28/1995	Burtnyk; Nestor et al.
67	US5477026	12/19/1995	Buongiorno; Angelo
68	US5478983	12/26/1995	Rancourt; Yvon
69	US5484980	1/16/1996	Pratt; Vanon D. et al.
70	US5512162	4/30/1996	Sachs; Emanuel et al.
71	US5530221	6/25/1996	Benda; John A. et al.
72	US5578227	11/26/1996	Rabinovich; Joshua E.
73	US5607730	3/4/1997	Ranalli; Ronald J.
74	US5612099	3/18/1997	Thaler; Stephen L.
75	US5620552	4/15/1997	Denney; Paul E.
76	US5640667	6/17/1997	Freitag; Douglas W. et al.
77	US5647931	7/15/1997	Retallick; David et al.

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78	US5688564	11/18/1997	Coddet; Christian Louis Michel et al.
79	US5697043	12/9/1997	Baskaran; Suresh et al.
80	US5786023	7/28/1998	Maxwell; James L. et al.
81	US5837960	11/17/1998	Lewis; Gary K. et al.
82	US5961858	10/5/1999	Britnell; James W.
83	US5985056	11/16/1999	McCay; Thurman Dwayne et al.
84	US5993550	11/30/1999	Eloy; Jean Fran.cedilla.ois Albert
85	US5993554	11/30/1999	Keicher; David M. et al.
86	US6046426	4/4/2000	Jeantette; Francisco P. et al.
87	US6122564	9/19/2000	Koch; Justin et al.
88	US6203861	3/20/2001	Kar; Aravinda et al.
89	US6268584	7/31/2001	Keicher; David M. et al.
90	US6306467	10/23/2001	White; Dawn Roberta et al.
91	US6316744	11/13/2001	Nowotny; Steffen et al.
92	US6344246	2/5/2002	Fischer; Eugene C. et al.
93	US6429402	8/6/2002	Dixon; Raymond D. et al.
94	US6476343	11/5/2002	Keicher; David M. et al.
95	US6504127	1/7/2003	McGregor; Gavin et al.
96	US6526327	2/25/2003	Kar; Aravinda et al.
97	US6534745	3/18/2003	Lowney; Mathew T. J.

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<u>PF</u> 98	US6548125	4/15/2003	Warnecke; Christian
<u>PF</u> 99	US6656409	12/2/2003	Keicher; David M. et al.
<u>PF</u> 100	US6703137	3/9/2004	Subramanian; Ramesh
<u>PF</u> 101	US6717106	4/6/2004	Nagano; Kazuhiko et al.

Foreign Patent Documents

Examiner <u>Initial*</u>	Document <u>Number</u>	Publication <u>Date</u>	Country or <u>Patent Office</u>	<u>Translation</u>
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Other Documents (including author, title, pertinent pages, etc.)

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References Cited by Applicants

While the filing of Information Disclosure Statements is voluntary, the procedure is governed by the guidelines of Section 609 of the Manual of Patent Examining Procedure and 37 C.F.R. §§ 1.97 and 1.98. To be considered a proper Information Disclosure Statement, Form PTO-1449 shall be accompanied by a copy of each listed patent or publication or other item of information and a translation of the pertinent portions of foreign documents (if an existing translation is readily available to the applicant), an explanation of relevance of each reference not in the English language, and should be submitted in a timely manner as set out in MPEP Sec. 609.

Examiners will consider all citations submitted in conformance with 37 C.F.R. § 1.98 and MPEP Sec. 609 and place their initials adjacent the citations in the spaces provided on this form. Examiners will also initial citations not in conformance with the guidelines which may have been considered. A reference may be considered by the Examiner for any reason whether or not the citation is in full conformance with the guidelines. A line will be drawn through a citation if it is not in conformance with the guidelines AND has not been considered. A copy of the submitted form, as reviewed by the Examiner, will be returned to the applicant with the next communication. The original of the form will be entered into the application file.

Each citation initialed by the Examiner will be printed on the issued patent in the same manner as references cited by the Examiner on Form PTO-892.

The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

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